

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

WON-ICK JANG, ET AL.

Application No.:

Filed:

For: **STICTION-FREE MICROSTRUCTURE  
RELEASING METHOD FOR  
FABRICATING MEMS DEVICE -  
UTILITY**

Art Group:

Examiner:

Assistant Commissioner for Patents  
Washington, D.C. 20231

**TRANSMITTAL OF FORMAL DRAWINGS**

Sir:

Enclosed herewith for filing in the above-identified U.S. Patent Application are the formal drawings, 8 sheets including 12 Figures. Applicant hereby authorizes any additional extension or petition fees under 37 C.F.R. §1.17 or credit for any overpayment to our Deposit Account No. 02-2666. A copy of the Fee Transmittal sheet is enclosed.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Dated: 12/28/00

  
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FIG. 1

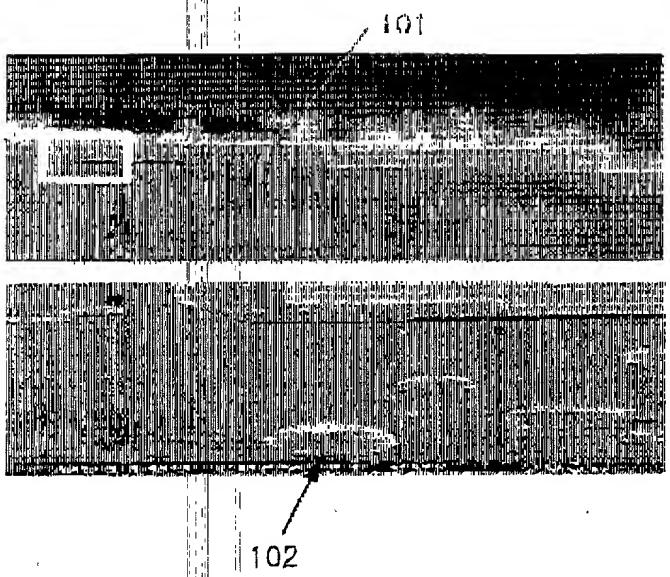


FIG. 2

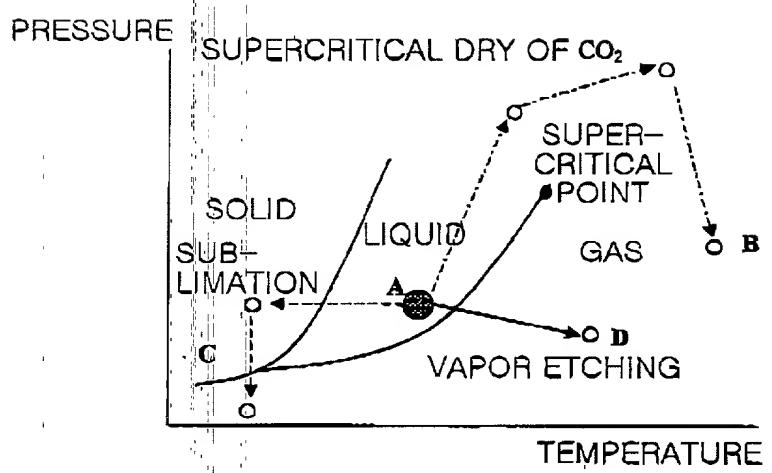


FIG. 3

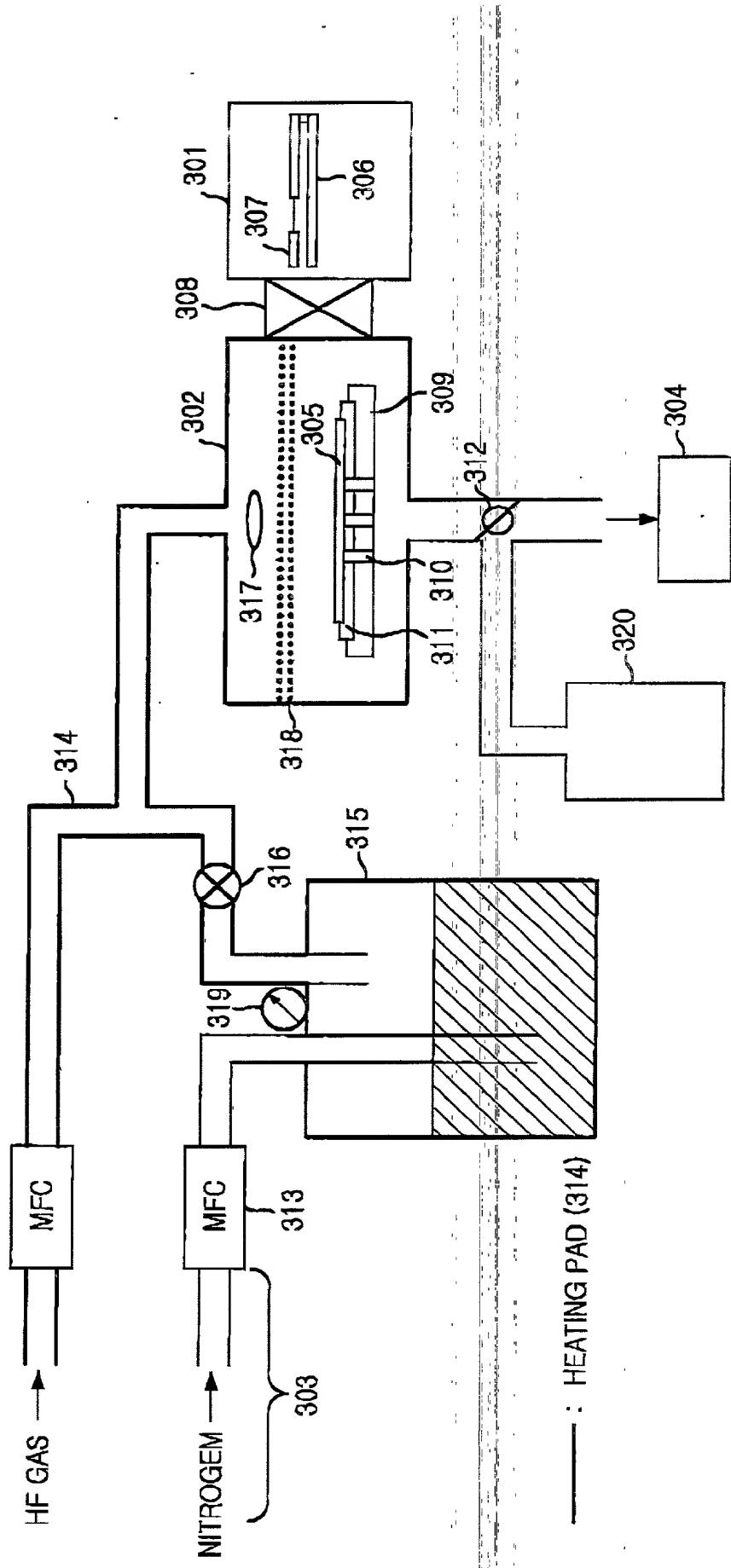
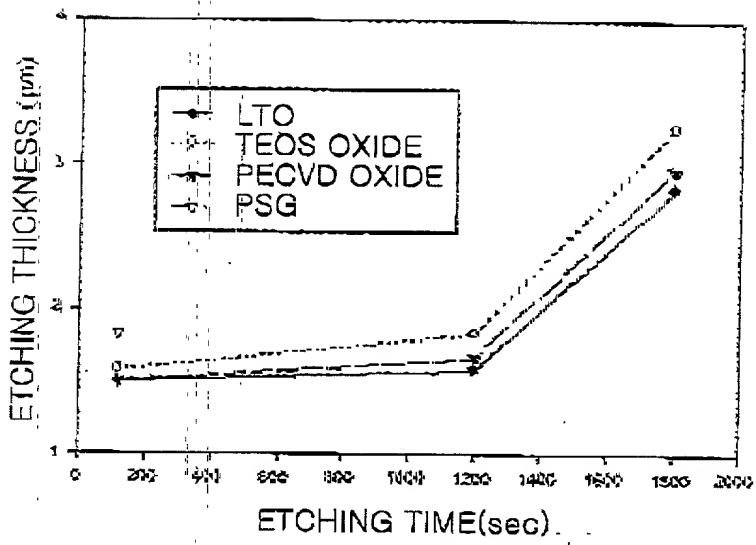


FIG. 4



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FIG. 5

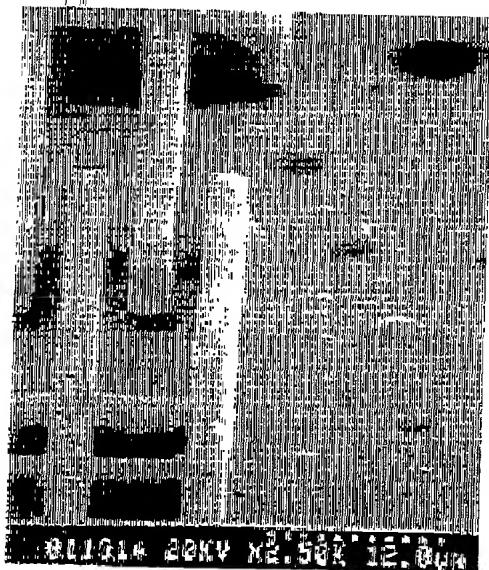


FIG. 6

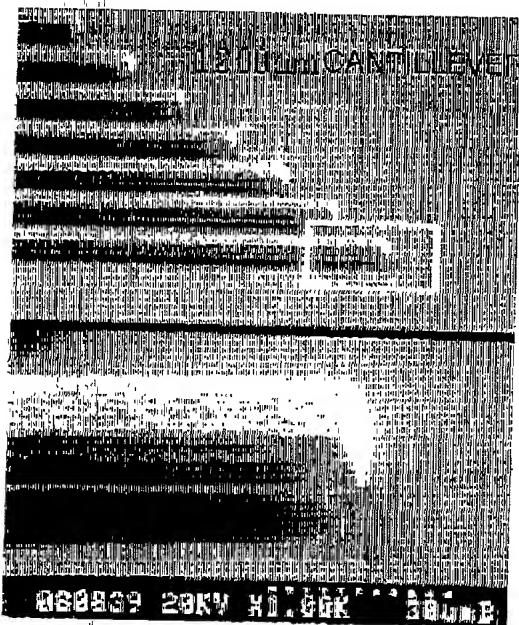


FIG. 7

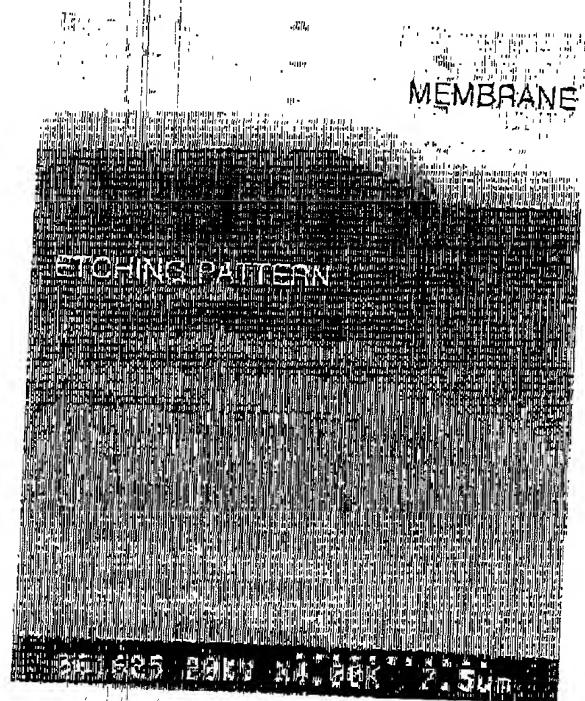
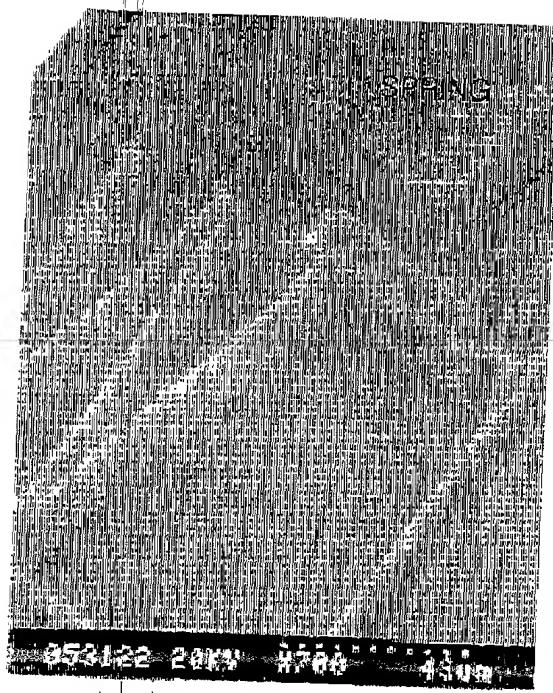


FIG. 8



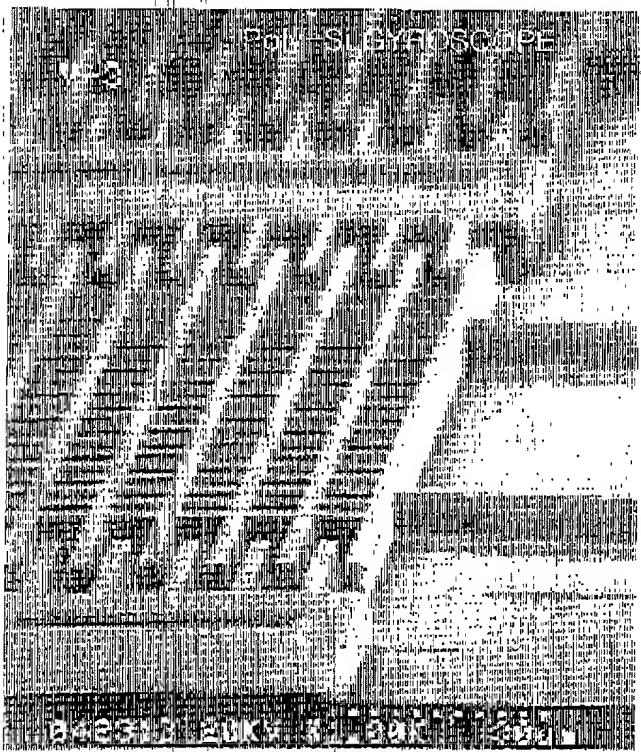
**FIG. 9****FIG. 10**

FIG. 11

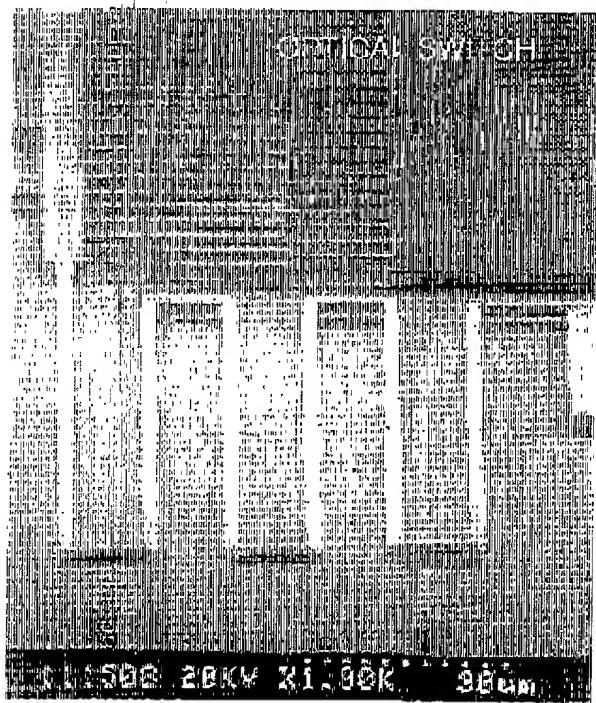


FIG. 12

